

<b>Notice of References Cited</b>	Application/Control No. 10/624,254	Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Jennifer C. McNeil	Art Unit 1775	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	C	US-6,805,725	10-2004	Hebsur, Mohan G.	75/245
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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